## Enhanced Thermoelectric Properties of Antimony Telluride Thin Films with Preferred Orientation Prepared by Sputtering a Fan-Shaped Binary Composite Target

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p-Type antimony telluride (Sb<sub>2</sub>Te<sub>3</sub>) thermoelectric thin films were deposited on BK7 glass substrates by ion beam sputter deposition using a fan-shaped binary composite target. The deposition temperature was varied from 100°C to 300°C in increments of 50°C. The influence of the deposition temperature on the microstructure, surface morphology, and thermoelectric properties of the thin films was systematically investigated. x-Ray diffraction results show that various alloy composition phases of the  $Sb_2Te_3$  materials are grown when the deposition temperature is lower than 200°C. Preferred c-axis orientation of the  $Sb_2Te_3$  thin film became obvious when the deposition temperature was above 200°C, and thin film with single-phase Sb<sub>2</sub>Te<sub>3</sub> was obtained when the deposition temperature was 250°C. Scanning electron microscopy reveals that the average grain size of the films increases with increasing deposition temperature and that the thin film deposited at 250°C shows rhombohedral shape corresponding to the original  $Sb_2Te_3$  structure. The room-temperature Seebeck coefficient and electrical conductivity range from  $101 \ \mu V \ K^{-1}$  to  $161 \ \mu V \ K^{-1}$  and  $0.81 \times 10^3 \ S \ cm^{-1}$  to  $3.91 \times 10^3 \ S \ cm^{-1}$ , respectively, as the deposition temperature is increased from  $100^{\circ}$ C to  $300^{\circ}$ C. An optimal power factor of  $6.12 \times 10^{-3}$  W m<sup>-1</sup> K<sup>-2</sup> is obtained for deposition temperature of  $250^{\circ}$ C. The thermoelectric properties of Sb<sub>2</sub>Te<sub>3</sub> thin films have been found to be strongly enhanced when prepared using the fan-shaped binary composite target method with an appropriate substrate temperature.

**Key words:** Thermoelectric thin films, antimony telluride, thermoelectric properties

## **INTRODUCTION**

Thermoelectric devices have attracted much attention for application as power generators, coolers, and thermal sensors or detectors due to their particular ability to interconvert heat and electric energy directly.<sup>1,2</sup> The performance of thermoelectric devices is evaluated by the materials' dimensionless figure of merit (*ZT*) or the power factor. *ZT* is defined as  $\alpha^2 \sigma T/\kappa$ , and the power factor is  $\alpha^2 \sigma$ ,

where  $\alpha$  is the Seebeck coefficient,  $\sigma$  is the electrical conductivity,  $\kappa$  is the thermal conductivity, and *T* is the temperature.<sup>3</sup> Antimony tellurium (Sb<sub>2</sub>Te<sub>3</sub>) is a well-established thermoelectric material that is used in the temperature range of 200 K to 400 K due to its high Seebeck coefficient and good electrical conductivity.<sup>4</sup> Significant progress has been made in recent years, and it has been found that thin-film technology can significantly reduce the thermal conductivity and increase the figure of merit *ZT* of thermoelectric materials.<sup>5,6</sup> Fabrication of thin-film thermoelectric materials and devices with high performance has attracted much

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